



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q78931

Hideaki ITO, et al.

Appln. No.: 10/736,588

Group Art Unit: 1756

Confirmation No.: 5729

Examiner: John A. McPherson

Filed: December 17, 2003

For:

PHOTOSENSITIVE TRANSFER MATERIAL COMPRISING THERMOPLASTIC RESIN LAYER AND INTERMEDIATE LAYER EACH HAVING SPECIFIED

SURFACE POTENTIAL, AND METHOD FOR PRODUCING COLOR FILTER

SUPPLEMENTAL RESPONSE

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In supplement to the Request for Reconsideration filed September 28, 2004, Applicants submit herewith a supplemental executed Rule 132 Declaration corresponding to the Rule 132 Declaration filed September 28, 2004 except for also including a statement under 18 U.S.C. 1001.

In view of the above, reconsideration and allowance of this application are now believed to be in order, and such actions are hereby solicited. If any points remain in issue which the Examiner feels may be best resolved through a personal or telephone interview, the Examiner is kindly requested to contact the undersigned at the telephone number listed below.

The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account.

Respectfully submitted,

Registration No. 33,725

Bruce E. Kramer

SUGHRUE MION, PLLC

Telephone: (202) 293-7060 Facsimile: (202) 293-7860

washington office 23373 customer number

Date: October 19, 2004



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For: PHOTOSENSITIVE TRANSFER MATERIAL COMPRISING THERMOPLASTIC RESIN LAYER AND INTERMEDIATE LAYER EACH HAVING SPECIFIED SURFACE POTENTIAL, AND METHOD FOR

PRODUCING COLOR FILTER

DECLARATION UNDER 37 C.F.R. § 1.132

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

I, Hideaki Ito, hereby declare and state:

THAT I am a citizen of Japan;

THAT I graduated from Graduate School of Science and Engineering, Tokyo Institute of Technology, Department of Chemistry in March, 1990.

THAT I joined Fuji Photo Film Co., Ltd., in 1990, and since then I have been engaged in development of a color filter for a liquid crystal display.

THAT I am an inventor of the invention described and claimed in the above-identified application;

THAT I am familiar with the prosecution of the above-identified application; and

THAT the experimentation set forth below was conducted by me or under my direct supervision.

EXPERIMENTATION

The closest specific embodiment disclosed in US 5,292,613, namely, sample (a) of Example 11 in the patent was tested. An absolute value of a surface potential of a separated thermoplastic resin layer of the sample was measured under the condition described in the present specification (at a separation speed of 1 m/min. under an atmosphere of 25℃ and 30 % RH). The surface potential was 7.3 kV.

The sample does not satisfy the claimed absolute value of a surface potential. This result shows that US '613 does not inherently disclose the presently claimed invention.

A conductive layer is provided only one side of a temporary support in US '613, and a reduction of electrostatic charge caused by separation is not enough. In order to avoid the electrostatic charge by separation, it is important to provide conductivity to a material on a substrate side.

I declare further that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Date: Oct. 1, 2004

Hideaki Ito